



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**ONO, Toshiaki et al.**

Group Art Unit: **1765**

Serial No.: **09/883,922**

Examiner: **ANDERSON, Matthew A.**

Filed: **June 20, 2001**

Confirmation No.: **3735**

For: **METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF  
PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR**

Attorney Docket No.: **010789**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.116**

Mailstop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

March 3, 2004

Sir:

In response to the Office Action dated September 11, 2003, Applicant amends the claims as follows and submits the following remarks.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.